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PATENT
Docket No. 20059/PIA31212

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant(s):

Jae Suk Lee

U.S. Serial No.: 10/748,468

For: "Methods for Forming
Shallow Trench Isolation
Structures"

Filed: December 30, 2003

Group Art Unit: 2812

Examiner: Not Yet Assigned

-) I hereby certify that this paper and the
documents referred to as enclosed
therewith are being deposited with the
United States Postal Service as first
class mail, postage prepaid, in an
envelope addressed to Commissioner
for Patents, P.O. Box 1450,
Alexandria, Virginia 22313-1450 on
this date:
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February 14, 2005
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James A. Flight
Attorney for Applicant(s)
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STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Kindly advise when an Office action can be expected in the above-referenced
matter.

Respectfully submitted,

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By:

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February 14, 2005